



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Group Art Unit: 1765

Serial No.: 10/024,958

In re Application of:

Confirmation No.: 3439

Filed:

December 18, 2001

For: Etch Process Photolithographic

Buie, et al.

Reticle Manufacturing with

Improved Etch Bias

Examiner:

Kin-Chan Chen

MAIL STOP Non-Fee Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Atexandria, VA 22313-1450.

Signature

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on January 20, 2004, with the United States Postal Service as

First Class Mail in an envelope addressed to: Mail Stop Non-

Fee Amendment, Commissioner for Patents, P.O. Box 1450,

Dear Sir:

RESPONSE TO OFFICE ACTION DATED OCTOBER 20, 2003

Date

In response to the Office Action dated October 20, 2003, having a shortened statutory period for response set to expire on January 20, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4213.P1/BKH, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks/Arguments begin on page 7 of this paper.